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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10099840	FILING DATE 03/12/2002	CLASS 436	SUBCLASS	GAU 2812	EXAMINER Q. DANG
**APPLICANTS: Hofmann James;					
**CONTINUING DATA VERIFIED: NONE					
** FOREIGN APPLICATIONS VERIFIED: NONE					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/> / RESCIND <input type="checkbox"/>					
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no Verified and Acknowledged Examiners's initials <i>my</i>				ATTORNEY DOCKET NO MI22-1803	
TITLE : Methods of forming patterns for semiconductor constructions; and molds configured to pattern masses associated with semiconductor constructions					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Assistant Examiner	
		Primary Examiner	
PREPARED FOR ISSUE		Application Examiner	
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